

#5/amdt A  
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C. McKenney

PATENT APPLICATION  
Docket No. 11675.23

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Cathey, et al. )  
Serial No.: 09/031,617 ) Art Unit 2822  
Filed: February 27, 1998 )  
For: MOCVD PROCESS USING OZONE AS A )  
REACTANT TO DEPOSIT A METAL OXIDE )  
BARRIER LAYER )  
Examiner: James Park )

AMENDMENT A UNDER 37 C.F.R. § 1.111

The Honorable Commissioner of Patents  
and Trademarks  
Washington, D. C. 20231

Sir:

In response to the Office Action mailed on November 26, 1999 (the "Office Action"), the Applicants submit this Amendment A and response.

IN THE DRAWINGS

Submitted herewith, by a separate paper, is a corrected Figure 1, sheet 1 of 2, as indicated in red. Support for the correction is found in the specification at Page 4, line 22. The Applicants request that any requirements for formal drawings be held in abeyance until such time as allowable subject matter has been indicated.

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